## Alexey Chernykh

## List of Publications by Citations

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18 30 353 11 h-index g-index citations papers 442 2.7 33 3.44 L-index avg, IF ext. citations ext. papers

#	Paper	IF	Citations
30	Electrical properties of bulk semi-insulating EGa2O3 (Fe). <i>Applied Physics Letters</i> , <b>2018</b> , 113, 142102	3.4	59
29	Hole traps and persistent photocapacitance in proton irradiated EGa2O3 films doped with Si. <i>APL Materials</i> , <b>2018</b> , 6, 096102	5.7	50
28	Hydrogen plasma treatment of EGa2O3: Changes in electrical properties and deep trap spectra. <i>Applied Physics Letters</i> , <b>2019</b> , 115, 032101	3.4	29
27	Electrical properties, structural properties, and deep trap spectra of thin £Ga2O3 films grown by halide vapor phase epitaxy on basal plane sapphire substrates. <i>APL Materials</i> , <b>2018</b> , 6, 121110	5.7	26
26	Electrical Properties, Deep Trap and Luminescence Spectra in Semi-Insulating, Czochralski EGa2O3 (Mg). <i>ECS Journal of Solid State Science and Technology</i> , <b>2019</b> , 8, Q3019-Q3023	2	25
25	Defects at the surface of EGa2O3 produced by Ar plasma exposure. APL Materials, 2019, 7, 061102	5.7	25
24	Deep trap spectra of Sn-doped EGa2O3 grown by halide vapor phase epitaxy on sapphire. <i>APL Materials</i> , <b>2019</b> , 7, 051103	5.7	22
23	Electrical Properties, Deep Levels and Luminescence Related to Fe in Bulk Semi-Insulating EGa2O3 Doped with Fe. <i>ECS Journal of Solid State Science and Technology</i> , <b>2019</b> , 8, Q3091-Q3096	2	19
22	Anisotropy of hydrogen plasma effects in bulk n-type EGa2O3. <i>Journal of Applied Physics</i> , <b>2020</b> , 127, 175702	2.5	14
21	Photosensitivity of Ga2O3 Schottky diodes: Effects of deep acceptor traps present before and after neutron irradiation. <i>APL Materials</i> , <b>2020</b> , 8, 111105	5.7	13
20	Pulsed fast reactor neutron irradiation effects in Si doped n-type EGa2O3. <i>Journal Physics D: Applied Physics</i> , <b>2020</b> , 53, 274001	3	13
19	Role of hole trapping by deep acceptors in electron-beam-induced current measurements in EGa2O3 vertical rectifiers. <i>Journal Physics D: Applied Physics</i> , <b>2020</b> , 53, 495108	3	11
18	Electric field dependence of major electron trap emission in bulk EGa2O3: PooleErenkel effect versus phonon-assisted tunneling. <i>Journal Physics D: Applied Physics</i> , <b>2020</b> , 53, 304001	3	9
17	Experimental estimation of electronfiole pair creation energy in EGa2O3. <i>Applied Physics Letters</i> , <b>2021</b> , 118, 202106	3.4	8
16	Schottky contacts to high-resistivity epitaxial GaAs layers for detectors of particles and X- or Fray photons. <i>Semiconductors</i> , <b>2012</b> , 46, 1066-1071	0.7	6
15	Investigation of the thermal annealing effect on electrical properties of Ni/Au, Ni/Mo/Au and Mo/Au Schottky barriers on AlGaN/GaN heterostructures. <i>Journal of Physics: Conference Series</i> , <b>2017</b> , 816, 012039	0.3	4
14	Effects of Hydrogen Plasma Treatment Condition on Electrical Properties of EGa2O3. ECS Journal of Solid State Science and Technology, 2019, 8, P661-P666	2	4

## LIST OF PUBLICATIONS

13	Crystal orientation dependence of deep level spectra in proton irradiated bulk EGa2O3. <i>Journal of Applied Physics</i> , <b>2021</b> , 130, 035701	2.5	4
12	Halide Vapor Phase Epitaxy of In2O3 and (In1⊠Gax)2O3 on Sapphire Substrates and GaN/Al2O3 Templates. <i>Physica Status Solidi (A) Applications and Materials Science</i> , <b>2021</b> , 218, 2000442	1.6	2
11	Fast-Neutron Detectors Based on Surface-Barrier GaAs Sensors with an Ultrahigh-Molecular-Weight Polyethylene Converter. <i>Instruments and Experimental Techniques</i> , <b>2019</b> , 62, 312-316	0.5	1
10	Deep traps and persistent photocapacitance in E(Al0.14 Ga0.86)2O3/Ga2O3 heterojunctions. <i>Journal of Applied Physics</i> , <b>2019</b> , 125, 095702	2.5	1
9	1 GeV proton damage in EGa2O3. Journal of Applied Physics, 2021, 130, 185701	2.5	1
8	Parasitic pfi junctions formed at V-pit defects in p-GaN. <i>Journal of Applied Physics</i> , <b>2021</b> , 129, 155702	2.5	1
7	Mo/Al/Mo/Au-based ohmic contacts to AlGaN/GaN heterostructures. <i>Russian Microelectronics</i> , <b>2016</b> , 45, 402-409	0.5	1
6	Electrical properties of EGa2O3 films grown by halide vapor phase epitaxy on sapphire with ECr2O3 buffers. <i>Journal of Applied Physics</i> , <b>2022</b> , 131, 215701	2.5	1
5	Structural and electrical properties of thick EGa2O3 grown on GaN/sapphire templates. <i>APL Materials</i> , <b>2022</b> , 10, 061102	5.7	1
4	Testing of a Prototype Detector of Heavy Charged Particles Based on Diamond Epitaxial Films Obtained by Gas-Phase Deposition. <i>Instruments and Experimental Techniques</i> , <b>2019</b> , 62, 473-479	0.5	O
3	Comparative Characteristics of GaAs Detectors and Silicon Pixel Detectors with Internal Amplification. <i>Materials Research Society Symposia Proceedings</i> , <b>2008</b> , 1108, 1		
2	Detectors on the Basis of High-Purity Epitaxial GaAs Layers for Spectrometry of X and Gamma Rays. <i>Instruments and Experimental Techniques</i> , <b>2018</b> , 61, 665-672	0.5	
1	GaAs Schottky Barrier Detectors for Alpha-Particle Spectrometry at Temperatures up to 120°C.  Technical Physics Letters, 2018, 44, 942-945	0.7	